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LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Kouichi OHTAKA, et al.

FILING DATE

January 18, 2002

GROUP

2873

COPY

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO
T.T.	AK	6-138403	05/20/94	JAPAN (with English Abstract)	/	X
	AL	7-218845	08/18/95	JAPAN (with English Abstract)	/	X
	AM	2000-2842	01/07/2000	JAPAN (with English Abstract)	/	X
	AN	10-510374	10/06/98	JAPAN (with corr. WO 96/41217)	/	X
	AO	WO 96/41217	12/19/96	WIPO	/	
	AP	2941952	08/30/99	JAPAN (with corr. WO 96/41224)	/	X
	AQ	WO 96/41224	12/19/96	WIPO	/	
	AR	3016871	03/06/2000	JAPAN (with corr. WO 96/41226)	/	X
T.T.	AS	WO 96/41226	12/19/96	WIPO	/	
	AT				/	
	AU					
	AV					

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

T.T.	AW	K. E. PETERSEN, Applied Physics Letters, vol. 31, no. 8, pages 521-523, "MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON", October 15, 1977
T.T.	AX	O. SOLGAARD, et al., Optics Letters, vol. 17, no. 9, pages 688-690, "DEFORMABLE GRATING OPTICAL MODULATOR", May 1, 1992
T.T.	AY	Larry J. HORNBECK, SPIE Critical Reviews Series, vol. 1150, pages 86-102, "DEFORMABLE-MIRROR SPATIAL LIGHT MODULATORS", August, 1989
	AZ	

Examiner

Tuyen Tra

Date Considered

5/03/2005

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.